

SYSTEM INFORMATION

Graphene specific Argon annealing system

PROCESS CONTAMINATION CLEARANCE PROCEDURE

- For using the argon annealing system a process clearance is mandatory. The detailed description of your sample mentioning the materials in the sample should be mailed to the system owner.
- Professor Incharge for Contamination clearance – Prof. Anil Kottantharayil.

Training Procedure and Authorization:

1. Contact the system owner after getting permission from the respective Professor/lab supervisor.
2. Get through with the training notes to understand the system and participate in process runs with the system owner or existing authorized user.
3. Get the training to open the gas cylinder depending on the required deposition.
4. To get authorization s/he must do 2-3 process runs on her/his own in presence of system owner and also answer and demonstrate the questions asked by system owner through operation of the system.

System owner

Email: truptiw@ee.iitb.ac.in